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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of

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Pradeep Subrahmanyam, Robert F. Hainsey,
and Weixiong Lu

Confirmation No. 7445

Application No. 10/777,973

Filed: February 11, 2004

For: **LASER PROCESSING OF A
LOCALLY HEATED TARGET
MATERIAL**

Group Art Unit: 1725

Examiner: M. Alexandra Elve

Date: October 13, 2005

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AMENDMENT

TO THE COMMISSIONER FOR PATENTS:

In response to the July 13, 2005 Office action, please amend the above-identified patent application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 7 of this paper.

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